

2813
JTFV

TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i>		Application Number	09/942,038
		Filing Date	August 30, 2001
		First Named Inventor	Yoshihiro MORI et al.
		Group Art Unit	2813
		Examiner Name	Yen-nhu B. Huynh
Total Number of Pages in This Submission		Attorney Docket Number	740819-637

ENCLOSURES (check all that apply)		
<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input checked="" type="checkbox"/> Amendment / Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Declaration and Power of Attorney <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s) _____	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input type="checkbox"/> Application Data Sheet <input type="checkbox"/> Request for Corrected Filing Receipt with Enclosures <input type="checkbox"/> A self-addressed prepaid postcard for acknowledging receipt <input type="checkbox"/> Other Enclosure(s) (please identify below):
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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual name	Donald R. Studebaker, Reg. No. 32,815 Nixon Peabody LLP 401 9 th Street, N.W. Suite 900 Washington, D.C. 20004-2128
Signature	
Date	November 16, 2004

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Yoshihiro MORI et al.) Group Art Unit: 2813
Serial No. 09/942,038) Examiner: Yen-nhu B. Huynh
Filed: August 30, 2001)
For: A METHOD FOR FABRICATING) Confirmation No. : 7302
SEMICONDUCTOR DEVICE INCLUDING)
ANNEALING LOWER ELECTRODE IN A)
REDUCING ATMOSPHERE BEFORE)
CAPACITOR INSULATING FILM FORMING)
(AS AMENDED))

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AMENDMENT

Mail Stop NON FEE Amendment
Commissioner for Patents
P.O. Box 1450
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Sir:

In response to the Office Action mailed August 16, 2004, please amend the above identified application as follows.

AMENDMENT TO THE TITLE:

Please amend the title to read as follows:

“METHOD FOR FABRICATING SEMICONDUCTOR DEVICE INCLUDING
ANNEALING LOWER ELECTRODE IN A REDUCING ATMOSPHERE BEFORE
CAPACITOR INSULATING FILM FORMING”